

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

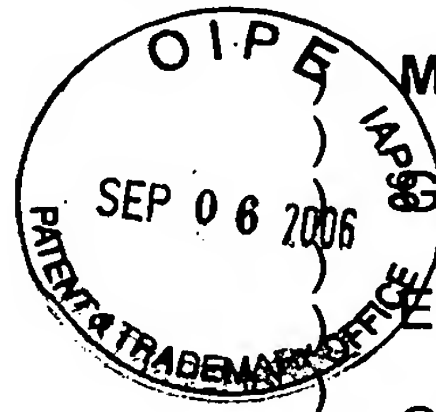
In re Patent Application of

Kari Harkonen et al.

Application No.: 10/642,426

Filed: August 15, 2003

For: DEPOSITION OF CARBON- AND
TRANSITION METAL-CONTAINING
THIN FILMS



MAIL STOP AMENDMENT

Group Art Unit: 1762

Examiner: BRET P. CHEN

Confirmation No.: 9896

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 7, 2006, please amend the
above-identified patent application as follows: